

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 89518
 Hui-Mei Chen, et al. : Confirmation Number: 3341
 Application No.: 10/786,807 : Group Art Unit: 2822
 Filed: February 25, 2004 : Examiner: Bac H. Au
 For: METHOD FOR IMPROVING :
 SEMICONDUCTOR WAFER :
 TEST ACCURACY :
 :

TRANSMITTAL

Mail Stop RCE
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

CERTIFICATE OF ELECTRONIC TRANSMISSION

I hereby certify that this correspondence is being electronically-transmitted to the
 United States Patent and Trademark Office on July 12, 2010.
/Tobi A. Herbert/
 Tobi A. Herbert

Dear Sir:

Transmitted herewith is a Request for Continued Examination and an Amendment, including a Petition for One-Month Extension of Time, in the above-identified application.

Also attached: Change to Large Entity Status
 The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	8	20	0	\$52.00 =	\$0.00
Independent Claims	3	3	0	\$220.00 =	\$0.00
Fee for extension of time				\$130.00	
Request for Continued Examination (RCE)				\$810.00	
Total of Above Calculations				\$940.00	

Please charge my Deposit Account No. 502624 in the amount of \$940.00.
 The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 502624, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

/Dennis A. Duchene/
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Please recognize our Customer No. 89518 as our correspondence address.

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Date: July 12, 2010